

12/22/00



U.S. PTO

12-27-00

A

Attorney Docket No. SEL 233

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
PATENT APPLICATION TRANSMITTAL LETTER

U.S. PTO  
09/747731



12/22/00

Transmitted herewith for filing is the patent application of:

1. Inventor(s): Shunpei YAMAZAKI and Takeshi FUKUNAGA
2. Title: Film Forming Apparatus And Method For Forming A Film

Name of applicant(s) and current correspondence address of applicant(s)

Name: Shunpei YAMAZAKI  
Residence: Tokyo, Japan  
Mailing Address: c/o Semiconductor Energy Laboratories, Co., Ltd., 398, Hase, Atsugi-shi, Kanagawa-ken 243-0036 Japan

Name: Takeshi FUKUNAGA  
Citizenship: Japanese  
Residence: Kanagawa, Japan  
Mailing Address: c/o Semiconductor Energy Laboratories, Co., Ltd., 398, Hase, Atsugi-shi, Kanagawa-ken 243-0036 Japan

Enclosed are:

- |              |              |   |
|--------------|--------------|---|
| <u>  X  </u> | <u>  7  </u> | Sheets of Drawings  |
|              |              | Formal  |
|              | <u>  X  </u> | Informal  |
| <u>  X  </u> |              | Assignment of invention to <u>Semiconductor Energy Laboratory Co., Ltd.</u> |
| <u>  X  </u> | <u> 27 </u>  | Pages of Specification  |
| <u>  X  </u> | <u>  5 </u>  | Pages of Claims   |
| <u>  X  </u> |              | Abstract of The Disclosure  |
| <u>     </u> |              | Statement of Small Entity   |
| <u>  X  </u> |              | Declaration and Power of Attorney   |
| <u>     </u> |              | Information Disclosure Statement  |

X   Appointment of Associate Attorneys

Applicants claim priority under 35 USC §119 to the following foreign application:

Serial no. 11-371349 filed December 27, 1999 in Japan.

  X   A certified copy of this priority document is enclosed herewith.

       Please enter the attached amendment before calculating the fees.

Claims as Filed

	Number Filed		Number Extra	Rate	Fee
Total	20	-20	0	(small entity) x 9 (others) x 18	\$0.00
Independent	8	-3	5	(small entity) x 40 (others) x 80	\$400.00
Multiple Dependent	No			(small entity) x 135 (others) x 270	\$0.00
Basic Fee				(small entity) x 355 (others) x 710	\$710.00
Assignment					\$40.00
Total Fee					\$1150.00

       Please charge my Deposit Account No. 50/1039 in the amount of \$ \_\_\_\_\_. A duplicate copy of this sheet is enclosed.

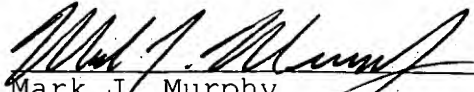
  X   The Commissioner is hereby authorized to charge any additional fees (except the issue fee) which may be required at any time during the prosecution of this application without specific authorization, or credit any overpayment to Deposit Account No. 50/1039. A duplicate copy of this sheet is enclosed.



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Date: December 20, 2000

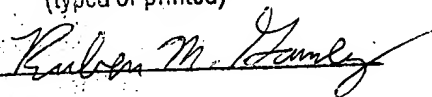
  
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Date of Deposit December 22, 2000

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Name Ruben M. Gamez  
(typed or printed)

Signature 

Attorney Docket No. SEL 233

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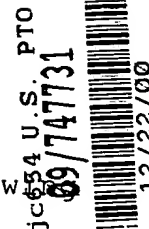
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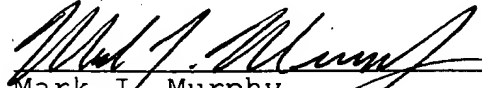
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Name: Ruben M. Gomez  
(typed or printed)

Signature Ruben M. Gomez